



101092528

To the Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof.

1. Name of conveying party(ies):

MITSUBISHI MATERIALS CORPORATION

2. Name and address of receiving party(ies): JUL 12 1999

NEW ENERGY AND INDUSTRIAL TECHNOLOGY
DEVELOPMENT ORGANIZATION
1-1, 3-Chome Higashi-Ikebukuro
Toshima-ku, Tokyo, Japan

3. Nature of conveyance: - ASSIGNMENT

Execution Date(s): May 26, 1999, _____,

_____, respectively.

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is as follows:

_____,
_____, respectively.

A. Patent Application No. (s)

B. Patent No.(s)

5,413,988

5. Name and address of party to whom correspondence concerning document should be mailed:

FRISHAUF, HOLTZ, GOODMAN, LANGER & CHICK, P.C.
767 Third Avenue, 25th Floor
New York, New York 10017-2023

6. Total number of applications and patents involved: 1

7. Total fee (37 CFR 3.41): \$ 40.00

[] Amount included with filing fee attached hereto.

[X] Check enclosed.

8. To the extent not tendered by check, authorization is given to charge the Assignment Fee (37 CFR.341) to Account No. 06-1378.

9. Statement and signature:

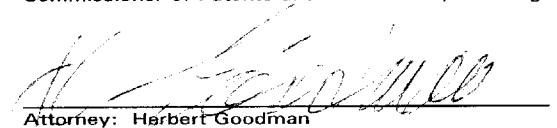
To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Dated: July 8, 1999

By: Herbert Goodman
Reg. No. 17,081

CERTIFICATE OF MAILING

I hereby certify this correspondence is being deposited with the United States Postal Service as First Class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231 on the date noted below.


Attorney: Herbert Goodman

Dated: July 8, 1999

ASSIGNMENT OF SHARE

We, Mitsubishi Materials Corporation, located at No. 6-1, Ohte-machi 1-chome, Chiyoda-ku, Tokyo 100 Japan, a corporation organized and existing under the laws of Country of Japan, the owner of the share of 50% of the entire right of the following U.S. Patent jointly with International Superconductivity Technology Center, located at 14-3 Shinonome 1-chome, Koto-ku, Tokyo 135 Japan, a corporation organized and existing under the laws of Country of Japan;

PATENT NO.	DATE ISSUED	INVENTOR	TITLE
5,413,988	MAY 9,1995	KUNIHICO HAYASHI ET AL	METHOD FOR MANUFACTURING AN OXIDE SUPERCONDUCTOR THIN FILM AND A TARGET FOR USE IN THE METHOD

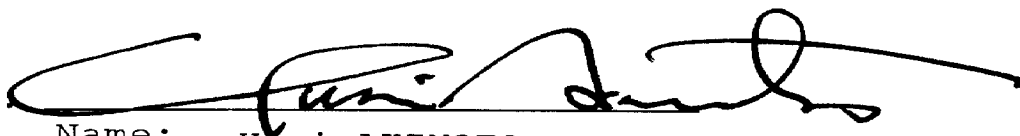
hereby assign the entirety of our share of the entire right, title and interest in said U.S. Patent to NEW ENERGY AND INDUSTRIAL TECHNOLOGY DEVELOPMENT ORGANIZATION, located at 1-1, 3-CHOME HIGASHI-IKEBUKURO TOSHIMA-KU, TOKYO, JAPAN, a corporation organized and existing under the laws of Country of Japan their successors, assigns, or other legal representatives.

The undersigned declares that he is authorized to sign this document on behalf of Mitsubishi Materials Corporation.

EXECUTED THIS 26th DAY OF May , 1999

Mitsubishi Materials
Corporation

By

A handwritten signature in black ink, appearing to read 'Yumi Akimoto', written over a horizontal line.

Name: Yumi AKIMOTO
Title: President